

Notice of References Cited	Application/Control No. 10/584,037	Applicant(s)/Patent Under Reexamination BAKKERS ET AL.	
	Examiner KENNETH HAMLIN	Art Unit 4148	Page 1 of 1

U.S. PATENT DOCUMENTS

*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Name	Classification
	A	US-			
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FOREIGN PATENT DOCUMENTS

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NON-PATENT DOCUMENTS

*		Include as applicable: Author, Title Date, Publisher, Edition or Volume, Pertinent Pages)
	U	"Different behavior of photoluminescence anisotropy in porous silicon layers made by polarized-light-assisted electrochemical etching" Hideki Koyama, Applied Physics Letters Vol. 80, number 6, 11 February 2002. Pages 965-967.
	V	"Fabrication of Metal Nanowires Using Microcontact Printing" Matthis Geissler et al. 2003 American Chemical Society Langmuir 2003, 19, 6301-6311.
	W	
	X	

*A copy of this reference is not being furnished with this Office action. (See MPEP § 707.05(a).)
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